Electronic Acknowledgement Receipt FES ID: 1224377 Application Number: 09700236 Confirmation Number: 3694 Crystal growth method for group-III nitride and related compound Title of Invention: semiconductors First Named Inventor: Xiong Zhang David H Jaffer Pillsbury Winthrop 2550 Hanover Street Correspondence Address: Palo Alto CA 94304-4040 US 6502334545 Filer: David Hussain Jaffer/Diana Dearing Filer Authorized By: David Hussain Jaffer Attorney Docket Number: 83973/269224 Receipt Date: 28-SFP-2006 Filing Date: 09-MAY-2001 Time Stamp: 13:12:12 Application Type: U.S. National Stage under 35 USC 371 International Application Number: Payment information:

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